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[10191/1808]

**REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP ART UNIT 1763**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Franz LAERMER et al.
Serial No. : 09/889,838
Filed : January 24, 2002
For : PLASMA ETCHING METHOD HAVING PULSED
SUBSTRATE ELECTRODE POWER
Examiner : Allan Olsen
Art Unit : 1763
Confirmation No. : 1541

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
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Date: Jan. 20, 2005

Signature: *Chili*

REPLY UNDER 37 C.F.R. § 1.116

S I R:

In response to the Final Office Action of July 30, 2003, kindly amend the above-captioned application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.